

Title (en)
PIEZOELECTRIC COMPONENT

Title (de)
PIEZOELEKTRISCHES BAUELEMENT

Title (fr)
COMPOSANT PIÉZOÉLECTRIQUE

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Abstract (en)
[origin: WO2010136367A1] The invention relates to a piezoelectric component comprising a stack (1) of piezoelectric layers (2, 2', 2'', 2''', 3, 3', 3'', 3''') arranged one on top of the other and first and second electrode layers (4, 5) arranged therebetween, wherein the stack (1) comprises at least one first piezoelectric layer (2) having a first electrical coercive force and directly adjacent thereto at least one second piezoelectric layer (3) having a second electrical coercive force different from the first coercive force.

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